FORM PTO-1449	Docket Number (Optional) 2080-3-176	Application Number 10/671,017
INFORMATION DISCLOSURE CITATION IN AN APPLICATION	Applicant: Mi Hyun Kim, et al.	
(Use several sheets if necessary)	Filing Date: September 25, 2003	Group Art Unit

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION (YES/NO)
/DZ/	11-161663	06/18/1999	JAPAN	G06F	17/30	YES (Abstract)
/DZ/	EP 0 872 839 A2	10/21/1998	EUROPE	G11B	20/12	YES (Abstract)
/DZ/	EP 0 737 009 A2	10/09/1996	EUROPE	H04N	5/92	YES (Abstract)
/DZ/	1020020006273 A	01/19/2002	KOREA	G11B	7/28	YES (Abstract)

OTHER DOCUMENTS ***(Including Author, Title, Date, Pertinent Pages, Etc.)***

EXAMINER	/Daquan Zhao/	DATE CONSIDERED	05/18/2007

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.